



Sheet 1 of 1

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| FORM PTO-1449 | U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE | ATTORNEY DOCKET NO. 1785.1016 | APPLICATION NO. 10/830,014 |
| INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) | | FIRST NAMED INVENTOR Kunio KOJIMA | |
| | | FILING DATE April 23, 2004 | GROUP/ART UNIT 3682 |

U.S. PATENT DOCUMENTS

| *EXAMINER INITIAL | | DOCUMENT NO. | DATE | NAME | CLASS | SUB- CLASS | FILING DATE |
|----------------------|----|-----------------|------|------|-------|---------------|----------------|
| | AA | | | | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AE | | | | | | |
| | AF | | | | | | |

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NO. | DATE | COUNTRY | TRANSLATION YES NO | | ABSTRACT |
|----|----|-----------------|------------|---------|-----------------------|---|----------|
| JR | AG | 2579835Y | 10/15/2003 | China | | X | |
| | AH | | | | | | |
| | AI | | | | | | |
| | AJ | | | | | | |
| | AK | | | | | | |
| | AL | | | | | | |

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

TRANSLATION
YES NO

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| | AM | | | |
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EXAMINER

/John Rivell/

DATE CONSIDERED

09/28/2006

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



ATTACHMENT 1(g)

| | | |
|---|----------------------|-----------------|
| LIST OF ADDITIONAL SUBMITTED DOCUMENTS | ATTORNEY DOCKET NO. | APPLICATION NO. |
| | 1785.1016 | 10/830,014 |
| | FIRST NAMED INVENTOR | |
| | Kunio KOJIMA et al. | |
| | FILING DATE | GROUP ART UNIT |
| | April 23, 2004 | 3682 |

The following document(s) is/are listed in accordance with the duty of disclosure provisions of 37 CFR § 1.56, so that the Examiner may consider same should he deem any thereof to be material to examination of the subject application.

It is requested that the Examiner acknowledge his consideration of document(s) below-listed by initialing same in the space provided adjacent each such application and that the Examiner sign and date this form at the bottom thereof to confirm such consideration having been given.

This submission in no way represents an admission that any of the information listed herein constitutes prior art with respect to the subject application; and unless and until such prior art status is established, this submission is not a request that the information presented herein be printed on the face of any patent issuing from the subject application in which this information is being filed.

U.S. PATENT DOCUMENTS

| *EXAMINER INITIAL | | DOCUMENT NO. | DATE | NAME | CLASS | SUB-CLASS | FILING DATE |
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| | AA | | | | | | |
| | AB | | | | | | |

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| | AC | | | | | | | |
| | AD | | | | | | | |

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

| | | | | TRANSLATION YES NO | |
|----|----|--|--|-----------------------|--|
| JR | AE | Chinese Office Action for Chinese Application No. 200410047719.7; dated February 10, 2006. | | X | |

| | |
|--|-------------------------------|
| EXAMINER /John Rivell/ | DATE CONSIDERED 09/28/2006 |
| *EXAMINER: Initial if document considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |